

Notice of References Cited	Application/Control No. 10/518,031		Applicant(s)/Patent Under Reexamination MILLER ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,127,078	06-1992	Terry et al.	385/116
*	B	US-6,418,267	07-2002	Lowry, Brian C.	385/147
*	C	US-6,817,746	11-2004	Steiner et al.	362/556
*	D	US-6,850,671	02-2005	Carnevale et al.	385/39
*	E	US-4,379,409	04-1983	Primbsch et al.	73/643
*	F	US-6,249,381	06-2001	Suganuma, Hiroshi	359/618
*	G	US-5,337,325	08-1994	Hwang, Cherng-Jia	372/36
*	H	US-6,011,885	01-2000	Dempewolf et al.	385/34
*	I	US-4,630,923	12-1986	Tans et al.	356/301
*	J	US-2005/0180706	08-2005	Jones, Michael I.	385/115
*	K	US-5,887,102	03-1999	Mueller et al.	385/115
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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